

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: R. TSUCHIYA et al  
Serial No. 10/372,329  
Filed: February 25, 2003

Group Art Unit: 2814  
Examiner: N.V. Ngo  
For: MIS SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Mail Stop Patent Application  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, the Applicants inform the Examiner of the documents cited during prosecution of the parent application, U.S. Serial No. 10/372,329.

The Applicants request the Examiner to initial and return a copy of the attached PTO-1449 form as an indication that the references have been considered.

Respectfully submitted,

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Date: April 16, 2004

FORM PTO-1449 (REV. 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. NIT-368-02	SERIAL NO.
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>		APPLICANT R. TSUCHIYA et al	
		FILING DATE April 16, 2004	GROUP

**U.S. PATENT DOCUMENTS**

* EXAMINER INITIAL	DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA	6,661,067	12/2003	Ngo et al		
	AB	6,399,451	6/2000	Lim et al		
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					

**FOREIGN PATENT DOCUMENTS**

DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
AL	7-245391	09/19/95	Japan (w/ English Abstract)		<input type="checkbox"/>	<input type="checkbox"/>
AM	5-3206	01/08/93	Japan (w/ English Abstract)		<input type="checkbox"/>	<input type="checkbox"/>
AN					<input type="checkbox"/>	<input type="checkbox"/>
AO					<input type="checkbox"/>	<input type="checkbox"/>
AP					<input type="checkbox"/>	<input type="checkbox"/>

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**

	AR	
	AS	
	AT	

EXAMINER	DATE CONSIDERED
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\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.